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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/462,796	01/13/2000	TAKAYOSHI WATANABE	500.38090X00	5528

7590

03/13/2003

ANTONELLI TERRY STOUT & KRAUS 1300 NORTH SEVENTEENTH STREET **SUITE 1800** ARLINGTON, VA 22209

**EXAMINER** NGUYEN, THANH T

ART UNIT PAPER NUMBER

2813

DATE MAILED: 03/13/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

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• ,•		Application N	o. <b>T</b>	Applicant(s)	1			
Office Action Summary		09/462,796		WATANABE ET AL.				
		Examin r		Art Unit				
		Thanh T. Nguy		2813				
	- Th MAILING DATE of this communication ap	pears on the cov	er sheet with t	he correspond nce addr ss	••			
THE N - Extension after S - If the	DRTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. sions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a rep period for reply is specified above, the maximum statutory period	.136(a). In no event, he ply within the statutory at will apply and will expite cause the application	owever, may a reply minimum of thirty (30 ire SIX (6) MONTHS on to become ABAND	be timely filed ) days will be considered timely. from the mailing date of this communic ONED (35 U.S.C. § 133).	cation.			
- Any re earner Status	e to reply within the set of extended period for reply with, by stated apply received by the Office later than three months after the mailing patent term adjustment. See 37 CFR 1.704(b).	ng date of this commu	ication, even il umer	y med, may reduce any				
1) 🗌	Responsive to communication(s) filed on 27	January 2003 .						
2a)	This action is <b>FINAL</b> . 2b)⊠ T	his action is nor	n-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
•	on of Claims							
	Claim(s) 34-53 is/are pending in the applicat							
	4a) Of the above claim(s) is/are withdr	awn from consid	leration.					
5)	Claim(s) is/are allowed.							
6)⊠	Claim(s) <u>34-53</u> is/are rejected.							
	Claim(s) is/are objected to.							
•	Claim(s) are subject to restriction and	or election requ	irement.					
	on Papers							
, —	The specification is objected to by the Examir		saataalta butbo	Evaminer				
10)[	The drawing(s) filed on is/are: a) acc				-			
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). 11) ☐ The proposed drawing correction filed on is: a) ☐ approved b) ☐ disapproved by the Examiner.								
בו(דד				·FF				
If approved, corrected drawings are required in reply to this Office action. 12) ☐ The oath or declaration is objected to by the Examiner.								
,	under 35 U.S.C. §§ 119 and 120			•				
	Acknowledgment is made of a claim for forei	ian priority unde	r 35 U.S.C. § 1	19(a)-(d) or (f).				
	☐ All b)☐ Some * c)☐ None of:	.g., p.,,	J	.,,,,				
α,	1. Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No							
	3. Copies of the certified copies of the prapplication from the International 8	riority documents Bureau (PCT Ru	s have been re ıle 17.2(a)).	ceived in this National Stag	je			
	See the attached detailed Office action for a li				lication)			
	Acknowledgment is made of a claim for dome				mounony.			
15) <u></u>	a)  The translation of the foreign language packnowledgment is made of a claim for dome	estic priority und	er 35 U.S.C. §	§ 120 and/or 121.				
Attachmer	nt(s)		<b>-</b>					
2) Noti	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) rmation Disclosure Statement(s) (PTO-1449) Paper No(s	5)	Interview Su  Notice of Info Other:	mmary (PTO-413) Paper No(s) ormal Patent Application (PTO-15;				

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#### **DETAILED ACTION**

# Specification

The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

# Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 34-53 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamaguchi et al. (U.S. Patent No. 6,271,110) or Akram et al. (U.S. Patent No. 5,592,736) or Takahiro et al. (JP patent No. 08191072) in view of Ochiai et al. (U.S. Patent No. 5,643,831) and Michihiko et al. (JP Patent No. 05206221).

Referring to figures, teaches a method of producing a semiconductor device comprising the steps of:

Forming a plurality of pyramidal bump electrodes (16/34) or the semiconductor device, and

Connecting the pyramidal bump electrodes to pad electrodes (32) of the semiconductor device,

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The step of forming the plurality of pyramidal bump electrodes including: a step of forming etched holes (see col. 5, lines 60-64) by anisotropically etching base material having a crystal orientation (see col. 8, lines 37-42), and

A step of filling up the etched holes by plating a metal (see col. 9, lines 17-20).

However, the reference does not teach etching a first oxidized film on the base material, removing the first oxidized film and forming a second oxidized film on the etched holes, forming a primary film of the same material as the metal for plating of the metal on the base material, and filling the metal such as gold/nickel, copper.

Ochiai et al. teaches a method of etching a first oxidized film on the base material, removing the first oxidized film and forming a second oxidized film on the etched holes (see figures 8A-8H and related text).

Therefore, it would have been obvious to a person of ordinary skill in the requisite art at the time of the invention was made would etch a first oxidized film on the base material, removing the first oxidized film and forming a second oxidized film on the etched holes in process of Yamaguchi et al. or Akram et al. as taught by Ochiai et al. because the process would bring the plate into a chemically stable condition and provides a low wetability to the plate, so a durability of the plate is improve and formed solder balls can be easily transferred.

Michihiko teaches forming a primary film of the same material as the metal for plating of the metal on the base material (see page 3, paragraph#7).

Therefore, it would have been obvious to a person of ordinary skill in the requisite art at the time of the invention was made would form a primary film of the same material as the metal for plating of the metal on the base material in process or Yamaguchi et al. or Akram et al. or

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Takahiro et al. as taught by Michihiko because the process would prevent generation of short-circuit.

It is known in the art to form the filling metal such as gold/nickel, copper.

Therefore, it would have been obvious to a person of ordinary skill in the requisite art at the time of the invention was made would form the filling metal such as gold/nickel, copper in process of Yamaguchi et al. or Akram et al. because process in known in the art since determining the optimum material for the layer only involved routine skill in the art.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanh Nguyen whose telephone number is (703) 308-9439, or by Email via address Thanh.Nguyen@uspto.gov. The examiner can normally be reached on Monday-Thursday from 6:30AM to 4:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, can be reached on (703) 308-4940. The fax phone number for this Group is (703) 308-7722.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-0956 (See MPEP 203.08).

Thanh Nguyen Patent Examiner

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